



-1-

Docket No.: S1432-700819


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yeshwanth Narendar et al.
Serial No: 10/752,434
Confirmation No: 3742
Filed: January 6, 2004
For: HIGH PURITY SILICON CARBIDE ARTICLES AND METHODS

Examiner: Karl E. Group
Art Unit: 1755

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 22nd day of May, 2006.


Stephanie Godino

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

In response to the Office Action mailed January 20, 2006, please amend the above-identified application as follows. Changes to the Claims are shown by strike through (for deleted matter) and underlining (for added matter).

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.